

| | rm-PTO-1595 51-92 | TRAN | 1016605 | 03 A | RDATION tty. Docket: 862.C2168 | ; | |
|---|---|--|----------------------|--|-----------------------------------|----------------------|--|
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| 1. | Name of conveying party(ies): | | | 2. Name and address of receiving party(ies): | | | |
| | Seiji TAKEUCHI Eiichi MURAKAMI | | | | Canon Kabushiki Kais | | |
| | Additional name(s) of conveying party(ies) attached? Yes No | | | Foreign Address: 30-2, Shimomaruko 3-chome, Ohta-ku, Tokyo, Japan | | | |
| 3. | Nature of conveyance: X Assignment Security Agreement Other | nt 🔲 Cha | rger ange of Name | Domestic Addre | ess: | 03/29/0.8 | |
| | Execution Date: (1) March 25, 2001 and (2 | | March 24, 2001 | i - | State | | |
| | | | | Additional name(s) & address(es) attached? Yes No | | | |
| 4. | Application number(s) or patent number(s): If this document is being filed together with a new application, the execution date of the application is: (1) March 25, 2001 and (2) March 24, 2001 | | | | | | |
| | A Patent Application Number | er: | | | Invention: | ic DEVICE | |
| | Filing Date: March 29, 2001 | | | STOCKER, EXPOSURE APPARATUS, DEVICE MANUFACTURING METHOD, SEMICONDUCTOR MANUFACTURING FACTORY, AND EXPOSURE APPARATUS MAINTENANCE METHOD | | | |
| | Additional numbers attached? | | | | | | |
| 5. | Name and address of party to concerning document should | ame and address of party to whom correspondence oncerning document should be mailed: | | 6. Number of | applications and patents | involved: | |
| | Name: Fitzpatrick, Cella, Harper & Scinto | | | One | | | |
| | 30 Rockefeller Plaza New York, New York 10112-3801 | | 7. Total fee (37 | 7 CFR 3.41): \$ | 40.00 | | |
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| 9. | Statement and signature. | · · · · · · · · · · · · · · · · · | | | | | |
| | To the best of my knowledge and belief, the foregoing information is true and the attached is the original document or is a true copy of the original document. | | | | | | |
| | Steven E. Warner (Reg. No. : | 33,326) | Jaren E. Like | ^€ ^ | | 29, 2001 | |
| - | Name of Person Signing | | | | | | |
| 1 | | To | tal number of page | es including cover | sheet, attachments, and d | locuments: 3 | |

SEW:ayr

PATENT REEL: 011666 FRAME: 0086

JOINT (BEFORE APPLICATION FILED)

ASSIGNMENT OF PATENT RIGHTS FOR THE UNITED STATES

FOR VALUE RECEIVED, We, Seiji TAKEUCHI and Eiichi MURAKAMI

citizens of Japan

Tochiqi, Japan both residing at

hereby sell, assign, transfer and convey unto

Canon Kabushiki Kaisha

a corporation of Japan

having a place of business at 30-2, Shimomaruko 3-chome, Ohta-ku, Tokyo, Japan

its successors, assigns and legal representatives (hereinafter called the "Assignee"), the entire right, title and interest, for the United States, in and to certain inventions relating to

STOCKER, EXPOSURE APPARATUS, DEVICE MANUFACTURING METHOD, SEMICONDUCTOR MANUFACTURING FACTORY, AND EXPOSURE

APPARATUS MAINTENANCE METHOD

and described in an application for Letters Patent of the United States executed by each of us, respetively, on the date indicated below and in and to said application, and all divisions, renewals and continuations thereof, and all Letters Patent of the United States which may be granted, thereon, and all reissues and extensions thereof; and we hereby authorize and request the Commissioner for Patents and Trademarks of the United States to issue all Letters Patent upon said inventions to the Assignee or to such nominees as it may designate.

AND we authorize and empower the said Assignee or nominees to invoke and claim for any application for patent or other form of protection for said inventions, the benefit of the right of priority provided by the International Convention for the Protection of Industrial Property, as amended, or by any convention which may henceforth be substituted for it, and to invoke and claim such right of priority without further written or oral authorization from us.

AND we hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any assignment, consent to file or like document which may be required in the United States for any purpose and more particularly in proof of the right of said Assignee or nominees to claim the aforesaid benefit of the right of priority provided by the International Convention for the Protection of Industrial Property, as amended, or by any convention which may henceforth be substituted for it.

AND we hereby covenant that we have the full right to convey the entire right, title and interest herein assigned and that we have not executed and will not execute any agreement in conflict herewith.

AND we hereby covenant and agree that we will communicate to said Assignee or nominees all facts known to us pertaining to said inventions, and testify in all legal proceedings, sign all lawful papers, execute all divisional, continuing and reissue applications, make all rightful oaths and declarations and in general perform all lawful acts necessary or proper to aid said Assignee or nominees in obtaining, maintaining and enforcing all lawful patent protection for said inventions in the United States.

By: Seji Takerich Date: March 25, 2001

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Ceichi Murakamı Date: March 34. 2001.

PATENT RECORDED: 03/29/2001 REEL: 011666 FRAME: 0088